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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Confirmation No. 9958
Masamichi NAKASHIBA et al. : Docket No. 2000-0722
Serial No. 09/589,388 : Group Art Unit 3723
Filed June 8, 2000 : Examiner George Nguyen

APPARATUS FOR AND METHOD FOR
POLISHING WORKPIECE

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TECHNOLOGY CENTER R3700

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of January 31, 2003, the period for response to which
having been extended by three months to July 31, 2003, kindly amend the above-referenced U.S.
patent application as follows:

IN THE SPECIFICATION

Please insert before BACKGROUND OF THE INVENTION in column 1 and after the
title the following:

REFERENCE TO RELATED APPLICATION

A continuation of this reissue application was filed May 13, 2002 and bears Serial No.
10/142,980.

IN THE CLAIMS

12. (Amended) A method of polishing a surface of a workpiece, comprising:
holding a workpiece by a top ring; and

S44
F1

F2